



# Development of a high-speed diagnostics package for the 0.2 J, 20 fs, 1 kHz repetition rate laser at ELI Beamlines

**Diagnostics** package

# Introduction



### Next-pulse interlock

Pulse energy and power are insufficient to diagnose subtle problems. Aberration indicators such as intensity distribution, change detection and spatial transforms, calculated from the beam profile, can be used to identify bright/dark spots, optical coating damage and amplifier instability. If an error is detected, **the next pulse from the L1 front-end is blocked**, giving the best possible chance of damage prevention. A fast switch stops any seed pulses reaching the amplifiers and prevents pulse emission. With the majority of the time taken up by the transfer of pixel data, on-line and parallel processing must be used to reach the µs latencies required.



# FPGA design

For rapid development, LabVIEW FPGA was used. As well as realtime image streaming, beam centroid and diameter according to ISO 11146 are calculated, together with a cumulative realtime pixel intensity histogram that helps identify bright spots caused by optical crystal damage. 425 million multiply-accumulate operations per second are carried out on the pixel data using Xilinx DSP slices.

## 1000 fps camera evaluation

To measure beam spatial properties on an every-shot basis requires a camera capable of taking **1000 frames per second at** high resolution.

A prototype testing platform was built to evaluated different highspeed cameras. It is based on an NI FPGA-based frame grabber in an industrial PC platform with real-time OS

The system was tested on the 10 mJ preamplifier pump laser in the far-field. Systematic differences were seen between cameras. Further testing and error analysis is therefore required.





At 1 kHz this information can also be used for pointing stabilisation, eliminating the need for additional sensors



#### Conclusions

We have introduced the diagnostics package for the L1 beamline. A 1 kfps camera-based beam profile analysis system has been built. Beam centroid, width, profile and histogram data can be measured and collected in real-time at 1 kHz. The system can detect errors and operate a **next-pulse interlock system** to block seed pulses at the laser front-end within a 1 ms window.

Algorithms for change detection and aberration indicators will be developed in the near future. We will monitor developments in high speed cameras and test all cameras systematically to address the sources of systematic error found in profile imaging.

ELI Beamlines is supported by:



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System front panel. Real-time histogram analysis gives early warning of amplifier instability that might be masked in measurements of pulse energy alone